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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re application of: NOVOTNY et al.

Attorney Docket No.: AONIP001C1

Application No.: 10/035,829

Examiner: UNASSIGNED

Filed: October 18, 2001

Group: 2874

Title: MICRO-OPTO-ELECTRO-MECHANICAL  
SWITCHING SYSTEM

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the  
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Signed

Sandra Halliwell

INFORMATION DISCLOSURE STATEMENT  
37 CFR §§ 1.56 AND 1.97(b)

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to the patentability of the above-identified patent application. Items 1 through 5 on the enclosed list of references are pending U.S. Patent Applications, from which this application claims priority or is related. Items 6 through 9 are articles or sections of books. Applicants submit the list in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the patentability of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. AONIP001C1).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

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**Form 449 (Modified)**

**Information Disclosure  
Statement By Applicant**

(Use Several Sheets if Necessary)

Atty Docket No.  
AONIP001C1

Applicant:  
NOVOTNY et al.

Filing Date  
10/18/2001

Application No.:  
10 035.829

Group  
2874

**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date

**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub- class	Translation	
							Yes	No

**Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	1	U.S. Patent Application No. 09/865,981, filed May 24, 2001
	2	U.S. Patent Application No. 60/206,744, filed May 24, 2000
	3	U.S. Patent Application No. 60/241,269, filed October 17, 2000
	4	U.S. Patent Application No. 09/880,456, filed June 12, 2001
	5	U.S. Patent Application No. 60/211,239, filed June 12, 2000
	6	U.S. Patent Application No. 09/981,628, filed October 15, 2001
	7	Elwenspoek, et al., "Silicon Micromachining" (1998)
	8	Nadim, "An Introduction to Microelectromechanical Systems Engineering" (2000)
	9	Rai-Choudhury, "Handbook of Microlithography, Micromachining, and Microfabrication" (1997)
	10	Conant, et al., "A Flat High-Pressure Cell for X-ray Scattering"

This form is to be filled out by the applicant or its attorney, and should be submitted to the Patent Office with the next communication to the applicant.